IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

	icant(s): g Date:	Jin-won Jun, et al. Herewith							
Title:	•	METHOD OF FORMING THICK METAL SILICIDE LAYER ON GATE ELECTRODE							
	ostal Service "E op Patent Applic	CERTIFICATE OF MAILING UNDER 37 C.F.R.§ 1.10 ail" Mailing Label Number EV322656675US I hereby certify that this paper or fee is being deposited with the United xpress Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated below and is addressed to action, P.O. Box 1450, Alexandria, Virginia 22313-1450.							
		Date Christopher J. Hren							
Comr P.O. 1	missioner f Box 1450	t Application or Patents ginia 22313-1450							
		INFORMATION DISCLOSURE STATEMENT							
Sir:	This Info	ormation Disclosure Statement is submitted:							
[]		under 37 CFR 1.129(a), or (First/Second submission after Final Rejection)							
[X]	(Within the three monor Office Act	under 37 CFR 1.97(b), or (Within three months of filing national application other than a CPA under §1.53(d); or within three months of date of entry of the national stage in international application; or before mailing date of first Office Action on the merits; or before mailing date of first Office Action after filing RCE under §1.114, whichever occurs last)							
[]	under 37	CFR 1.97(c) together with either:							
	[] a	Statement under 37 CFR 1.97(e), as checked below, or							
1	(.	the \$180.00 fee under 37 CFR 1.17(p), or After the 37 CFR 1.97(b) time period, but before final action or notice of allowance, r other action which closes prosecution, whichever occurs first)							
[]	under 37	under 37 CFR 1.97(d) together with:							
	[] a	Statement under 37 CFR 1.97(e), as checked below, and							
	()	he \$180.00 fee set forth in 37 CFR 1.17(p). Filed after final action or notice of allowance, whichever occurs first, but before ayment of the issue fee)							

Applicant(s): Jin-won Jun, et al.

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abstract.

Statement Under 37 1.97(e)

	[]	Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.						
	[]	No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.						
Enclosed herewith is form PTO-1449:								
[X]	Copies of cited references are enclosed.							
[]	Copies of cited references are enclosed except those entered in prior application, U.S. Serial No, and references that are not required to be submitted under 37 CFR 1.98.							
[]	The listed references were cited in a counterpart foreign application.							
Concis	se Explanation	Requirement (non-English references):						
[] satisfie		explanation" requirement under 36 CFR 1.98(a)(3)(i) for reference XX is						
	[] the exp	planation provided on the attached sheet.						

It is requested the information disclosed herein be made of record in this application.

the explanation provided in the Specification.

Applicant(s): Jin-won Jun, et al. Method of payment: Enclosed is a check in the amount of _____. [] Please charge Deposit Account of 50-1798 in the amount of _____. [] [] Two duplicate copies of this Statement are enclosed. Please charge any deficiency in fees and credit any overpayment to Deposit Account [X] No. 50-1798. Respectfully submitted, Mills & Onello, LLP Steven M. Mills Eleven Beacon Street, Suite 605 Registration Number 36,610 Boston, Massachusetts 02108 Attorney for Applicants Telephone: (617) 994-4900

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Facsimile: (617) 742-7774

						Sheet 2 of -						
Subst. Fo	rm PTO-	1449		Docket Number (Optional) SAM-0498		Application Number						
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U. S. Patent Documents												
EXAMINER INITIAL		DOCUMENT NUMBER	DATE		AME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE				
	AA	6,423,634	7/23/02	Wieczo	orek, et al.	438	655	4/25/00				
	AB	6,376,320	4/23/02		Yu	438	303	11/15/00				
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.												